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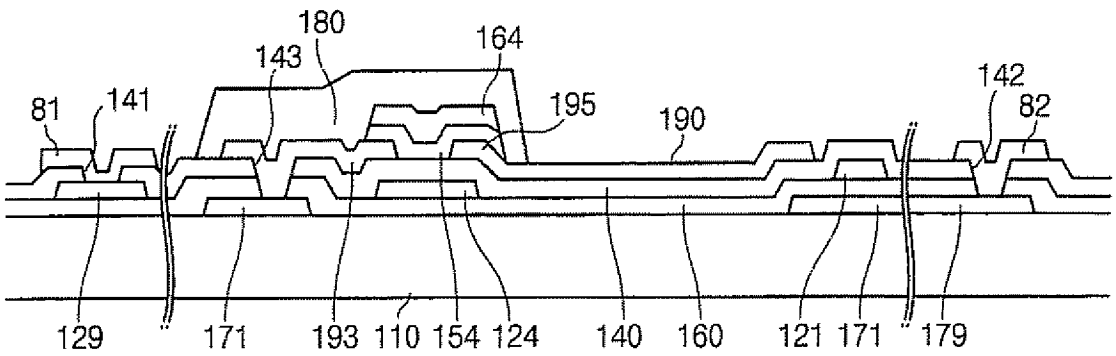
(54) Organic thin film transistor for an OLED display

(57) A method of manufacturing a thin film transistor array panel is provided, the method includes: a substrate; a data line disposed on the substrate; an interlayer insulating layer disposed on the data line; a gate line disposed on the interlayer insulating layer and including a gate electrode; a gate insulating layer disposed on the gate line and the interlayer insulating layer, the gate insulating layer and the interlayer insulating film having a contact hole exposing the data line; a first electrode disposed on the gate insulating layer and connected to the data line through the contact hole; a second electrode disposed opposite the first electrode with respect to the gate electrode; an organic semiconductor disposed on the first and the second electrodes and contacting the first and the second electrodes; and a passivation member disposed on the organic semiconductor.

Fig. 2



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EUROPEAN SEARCH REPORT

Application Number
EP 05 10 8029

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The present search report has been drawn up for all claims

Place of search	Date of completion of the search	Examiner
The Hague	1 February 2010	Persat, Nathalie

CATEGORY OF CITED DOCUMENTS

X : particularly relevant if taken alone
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A : technological background
O : non-written disclosure
P : intermediate document

T : theory or principle underlying the invention
E : earlier patent document, but published on, or after the filing date
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L : document cited for other reasons

& : member of the same patent family, corresponding document

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ANNEX TO THE EUROPEAN SEARCH REPORT ON EUROPEAN PATENT APPLICATION NO. EP 05 10 8029

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For more details about this annex : see Official Journal of the European Patent Office, No. 12/82

专利名称(译)	用于OLED显示器的有机薄膜晶体管		
公开(公告)号	EP1675195A3	公开(公告)日	2010-03-10
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[标]申请(专利权)人(译)	三星电子株式会社		
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当前申请(专利权)人(译)	SAMSUNG ELECTRONICS CO.，LTD.		
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CPC分类号	H01L27/283 H01L27/3244		
优先权	1020040108171 2004-12-17 KR		
其他公开文献	EP1675195A2		
外部链接	Espacenet		

摘要(译)

提供一种制造薄膜晶体管阵列面板的方法，该方法包括：基板;数据线设置在基板上;层间绝缘层设置在数据线上;栅极线，设置在层间绝缘层上并包括栅电极;栅极绝缘层设置在栅极线和层间绝缘层上，栅极绝缘层和层间绝缘膜具有暴露数据线的接触孔;第一电极，设置在栅极绝缘层上，并通过接触孔连接到数据线;第二电极相对于栅电极与第一电极相对设置;有机半导体，设置在第一和第二电极上并与第一和第二电极接触;钝化构件设置在有机半导体上。

Fig. 2